

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re Application of:

KOBAYASHI, *et al.*

Serial No.: 10/585,994

Filed: 13 July 2006

For: MANUFACTURING METHOD OF SEMICONDUCTOR  
DEVICE AND FILM DEPOSITION SYSTEM

**Confirmation No. 8859**

Art Unit: 2823

Examiner: Kevin A. Paredo

Atty. Dckt: 033082M336

**RESPONSE UNDER 37 C.F.R. 1.111**

Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

**Mail Stop: Amendment**

Dear Sir:

This is in response to the Office Action mailed January 28, 2009, to which the time for response was set to expire April 28, 2009. A Petition for an Extension of Time and the requisite fee are submitted herewith to extend the date for response to July 28, 2009. The pending claims, claims 1-12, were rejected. Reconsideration and entry of the following amendment(s) are respectfully requested.

Amendment to the Claims begins on page 2 of this paper.

Amendment to the Drawings begins on page 4 of this paper.

Remarks begin on page 5 of this paper.